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Microstructure stability of silver electrodeposits at room temperature

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In situ quantitative X-ray diffraction analysis was used to investigate the kinetics of microstructure evolution at room temperature (self-annealing) in an electrodeposited silver layer. As a function of time at room temperature the as-deposited nanocrystalline microstructure evolved considerably: orientation-dependent grain growth and changes of the preferred grain orientation occurred. It is demonstrated for the first time that self-annealing occurs for electrodeposited silver layers and, hence, is not a unique feature of copper as often suggested.

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Silver is increasingly attracting attention as a potential interconnect material [1,2] and the replacement of copper by silver in the future is being discussed in similar terms to those previously used for the changeover from aluminum-based materials to copper. Indeed, the lower electrical resistivity of bulk silver compared to bulk copper is promising; however, the properties finally depend on the microstructure of the films. For electrodeposited copper it is well known that the as-deposited microstructure is not stable, but evolves as a function of time at room temperature (self-annealing) (e.g. [3–6]), and changes may continue at elevated temperatures [7,8]. The microstructural evolution during self-annealing of copper electrodeposits is accompanied by considerable improvements in the electrical conductivity and electromigration resistance, and is hence of importance for the functionality of copper interconnects.

For silver electrodeposits, the thermal stability of the microstructure and associated properties has been investigated at elevated temperatures [9,10], but to the knowledge of the authors, self-annealing of silver layers at room temperature has not been reported previously. So far, evolution of the microstructure at room temperature has only been observed in bulk nanocrystalline

materials during mechanical loading [11–14] or in thin copper films [3–6,15].

Silver was electrodeposited from a commercial cyanide electrolyte (Engbright) containing $45 \text{ g l}^{-1} \text{ AgCN}$, $165 \text{ g l}^{-1} \text{ KCN}$, $15 \text{ g l}^{-1} \text{ K}_2\text{CO}_3$ and appropriate additive concentrations (Engbright S101 and S201). The bath temperature was 21°C . A $4 \mu\text{m}$ thick silver layer was deposited with a current density of 2.75 A dm^{-2} on a copper sheet.

For investigating the kinetics of self-annealing in situ X-ray diffraction (XRD) analysis was started immediately after the silver layer was deposited, cleaned, dried and mounted in the X-ray diffractometer (Discover D8, Bruker AXS), i.e. within about 15 min after deposition. $\text{CuK}\alpha$ radiation was used to measure the diffraction lines corresponding to (111), (200) and (222) lattice planes. Line profiles were fitted by applying pseudo-Voigt functions and microstructure information in terms of grain size and microstrain was obtained by applying both the single-line method [16] and the Williamson–Hall method [17] after correction for instrumental line broadening. In addition to repeated measurements of various diffraction lines, quantitative crystallographic texture analysis was also performed in turn with the line scans. For texture analysis, 111 and 220 pole figures were recorded (measurements were restricted to quarters of the pole figures, which are representative due to the presence of fibre textures) and the orientation distribution function was calculated. Scans of the various

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Figure 1. Diffraction lines from (111) and (200) lattice planes parallel to the surface measured about 15 min after deposition (thick drawing) and two weeks after deposition (thin drawing).

XRD lines and crystallographic texture analysis were performed repeatedly in turn until the recorded data stabilized. For the present example, in situ XRD studies were continued over a period of more than two weeks without any interruption.

The widths and intensities of the measured diffraction line profiles changed drastically as a function of time at room temperature (see Figs. 1 and 2).

Pseudo-Voigt fitting revealed pure Lorentzian shapes¹ of the diffraction line profiles, and hence it is suggested that the line broadening is mainly affected by the size of coherently diffracting domains (interpreted as grain size). The conclusion that microstrain does not contribute significantly to line broadening is supported by the evaluation of the hkh diffraction lines. Identical grain sizes were calculated from both the 111 and the 222 single-line profiles. The Williamson–Hall plot using only the 111 and 222 reflections yielded horizontal curves, indicating that no dependence of the line width on the diffraction angle, and, thus, no measurable influence of microstrain for $\langle 111 \rangle$ oriented grains were observed.

The as-deposited microstructure consisted of nanocrystalline grains with only slight orientation dependence (cf. Fig. 3). After a short incubation time considerable growth of grains with $\langle 111 \rangle$ orientation occurred and grain sizes approached (and certainly exceeded) the maximum values quantifiable under the applied XRD conditions (cf. [18]). In contrast, only negligible growth of $\langle 100 \rangle$ oriented grains occurred and after two weeks the $\langle 100 \rangle$ grains were only about 30 nm.

The evolution of the as-deposited microstructure by grain growth during self-annealing is accompanied by changes of the dominant grain orientation as indicated by the observed kinetics of the integrated intensities (Fig. 2b) and quantitative texture analysis (Fig. 4). For the as-deposited silver layer a single $\langle 100 \rangle$ fibre texture was present (Fig. 4a). This $\langle 100 \rangle$ texture with a rather strong as-deposited orientation density of 5.0 became weaker during self-annealing and at the same time a $\langle 211 \rangle$ texture developed. About two weeks after deposition the $\langle 211 \rangle$ texture became very broad and reached an orientation density of 3.9 (Fig. 4b).

Figure 2. (a) Full width at half maximum (FWHM), and (b) integrated intensity, I_{int} , at room temperature as a function of time, t , after deposition. Data corresponding to the 111 diffraction lines (black squares) and 200 diffraction lines (grey triangles) are shown.

Figure 3. Grain size, d , of $\langle 111 \rangle$ (squares) and $\langle 100 \rangle$ (triangles) oriented grains calculated from the widths of 111 and 200 diffraction lines measured as function of time, t (cf. Fig. 2a).

Figure 4. Inverse pole figures in normal direction of the silver layer as-deposited (a) and two weeks after deposition (b). Levels: 1.0, 1.5, 2.0, 2.5, 3.0, 3.5, 4.0, 4.5.

The present work clearly demonstrates that self-annealing also occurs for electrodeposited silver layers, and hence is not a unique feature of copper as often suggested.

Self-annealing in silver electrodeposits shows some similarities to the well known self-annealing behavior of electrodeposited copper layers. For both materials the as-deposited microstructure consisting of nanocrystalline grains with strong preferred grain orientations transforms during room temperature storage into a self-annealed microstructure with considerably larger grains and altered preferred orientations—however, some remarkable differences in the self-annealing behavior of the two materials were observed. For both copper and silver electrodeposits the kinetics of self-annealing was found to depend on the film thickness (not shown here) and the grain orientation. For both materials, grains not constituting the dominant orientation in the

¹Slight Gaussian contributions were detected only for the very first measurements after deposition.

as-deposited microstructure grow first: for copper, these are the $\langle 100 \rangle$ oriented grains in the as-deposited strongly $\langle 111 \rangle$ oriented microstructure, and for silver, these are the $\langle 111 \rangle$ grains in the as-deposited microstructure with preferred $\langle 100 \rangle$ orientation. In contrast to copper, where grains of the major texture component (the $\langle 111 \rangle$ grains) also finally grow, albeit at a slightly later stage [3,4], in silver, electrodeposited grains with the dominant as-deposited orientation (the $\langle 100 \rangle$ grains) remain almost unaffected for quite long times, at least within the period of investigation. A further peculiarity of self-annealing in silver is the evolution of a new strong crystallographic texture simultaneously with the weakening of the as-deposited preferred orientation, whereas copper electrodeposits [3,4] tend to become randomly oriented during self-annealing.

The results indicate the importance of the as-deposited crystallographic texture for the kinetics of the microstructure evolution at room temperature.

Based on the observed kinetics of grain growth and crystallographic texture changes during room temperature storage of electrodeposited silver it is concluded that any successful application of silver layers must allow for the effect of self-annealing on the microstructure.

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